

PATENT ASSIGNMENT COVER SHEET

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 Stylesheet Version v1.2

EPAS ID: PAT6078687

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
GE PHOSPHORS TECHNOLOGY, LLC	12/27/2019

RECEIVING PARTY DATA

Name:	GE PHOSPHORS TECHNOLOGY, LLC
Street Address:	1 RESEARCHCIRCLE,
City:	NISKAYUNA,
State/Country:	NEW YORK
Postal Code:	12309
Name:	DENKA COMPANY LIMITED
Street Address:	1-1, NIHONBASHI-MUROMACHI 2-CHOME, CHUO-KU,
City:	TOKYO
State/Country:	JAPAN
Postal Code:	103-8338

PROPERTY NUMBERS Total: 10

Property Type	Number
Application Number:	14176442
Application Number:	13303907
Application Number:	12668074
Application Number:	14248664
Application Number:	13500803
Application Number:	15371747
Application Number:	14166231
Application Number:	11944052
Application Number:	15788302
Application Number:	12171946

CORRESPONDENCE DATA

Fax Number: (703)739-2815

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Email: iprecordals@cpaglobal.com

PATENT

Correspondent Name: CPA GLOBAL LIMITED
Address Line 1: LIBERATION HOUSE
Address Line 2: CASTLE STREET
Address Line 4: ST HELIER, JERSEY JEI IBL

NAME OF SUBMITTER: HEIDI WHITTINGHAM

SIGNATURE: /IPR/NW/Soei/IPR_2020_001/AG/10P/

DATE SIGNED: 04/27/2020

Total Attachments: 2

source=US-Denka Patent Assignment (signed by GE)(for Denka April 23, 2020)#page1.tif

source=US-Denka Patent Assignment (signed by GE)(for Denka April 23, 2020)#page2.tif

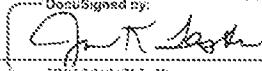
Assignment

We, the undersigned, GE Phosphors Technology, LLC ("GE"), having a place of business at 1 Research Circle, Niskayuna, NY 12309, United States of America, for valuable consideration, do hereby assign and convey an undivided one-half right, title, and interest in, effective as of December 27, 2019 (the "Effective Date"), to the patents listed in Schedule A attached herewith ("GE Patents"), to Denka Company Limited, a corporation organized under the laws of Japan, with an office at 1-1, Nihonbashi-Muromachi 2-chome, Chuo-ku, Tokyo 1038338, Japan ("COMPANY"). GE and COMPANY are referred to herein collectively as the "Parties" and each individually as a "Party".

Further, we do hereby give consent to COMPANY to take solely in its name all necessary procedures for recording this assignment at the patent office of the United States, on the basis of the assignment herein made.

In witness thereof, the Parties have executed this Assignment.

GE Phosphors Technology, LLC

DocuSigned by:
By: 

102CDB484796425

Printed Name: Jean K. Testa

Title: Vice President, GE Phosphors Technology, LLC

Date: 4/14/2020

Denka Company Limited

By: 山本 学

Printed Name: Manabu YAMAMOTO

Title: Representative Director, President and Chief Executive Officer, Denka Company Limited

Date: 04/14/2020

SCHEDULE A

List of U.S. GE Patents

U.S. Patent
US9356203
US8686631
US8084942
US9496463
US8709283
US9884990
US9624427
US8663498
US10259997
US7808012